

FIG. 1

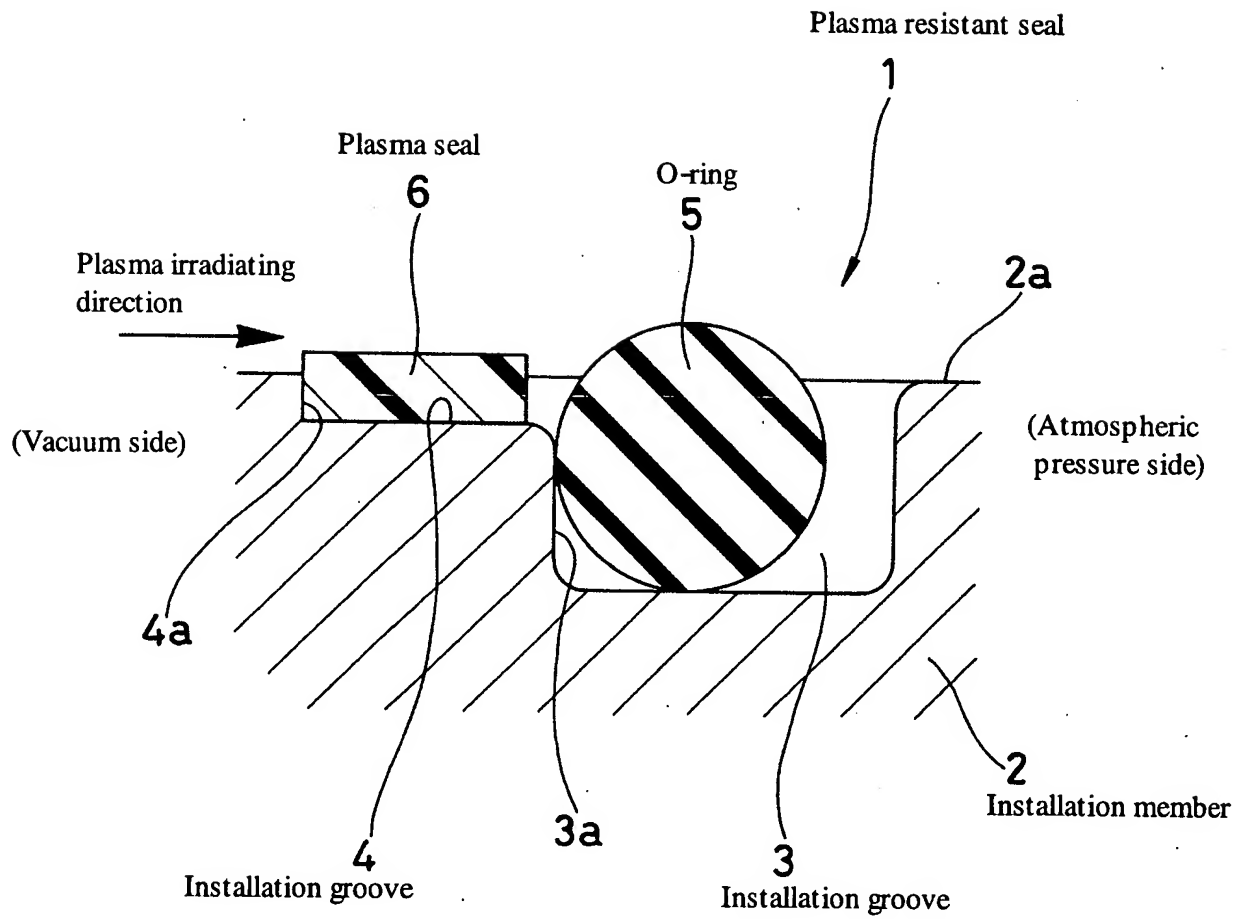


FIG. 2

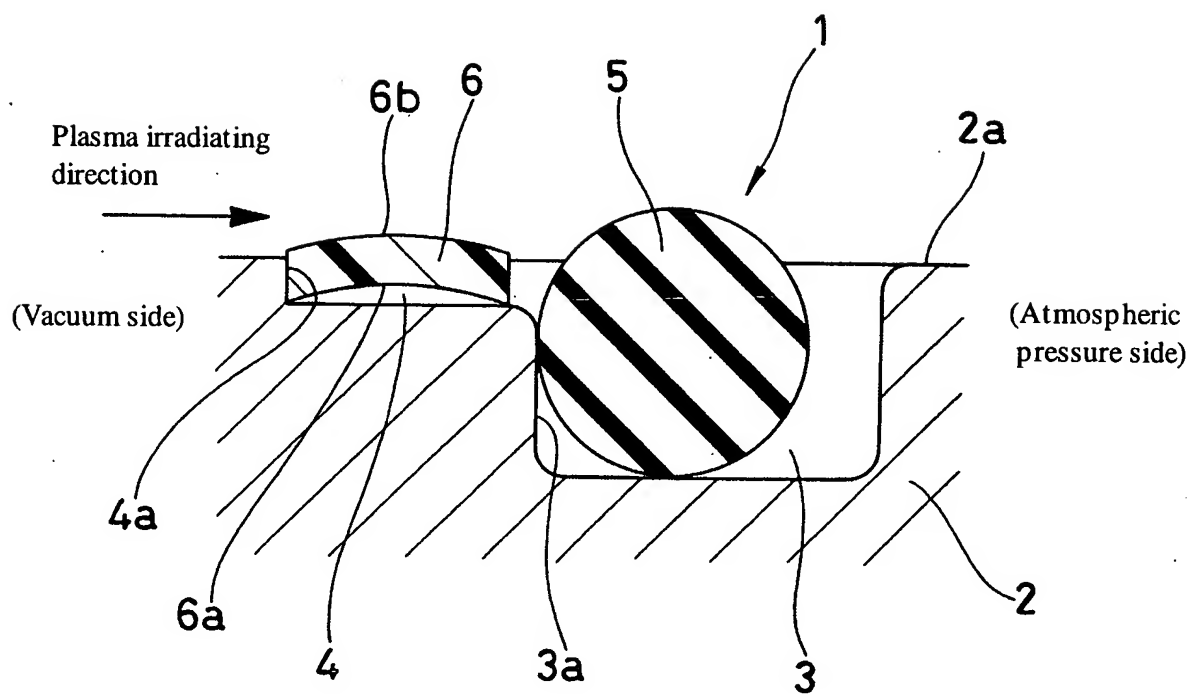


FIG. 3

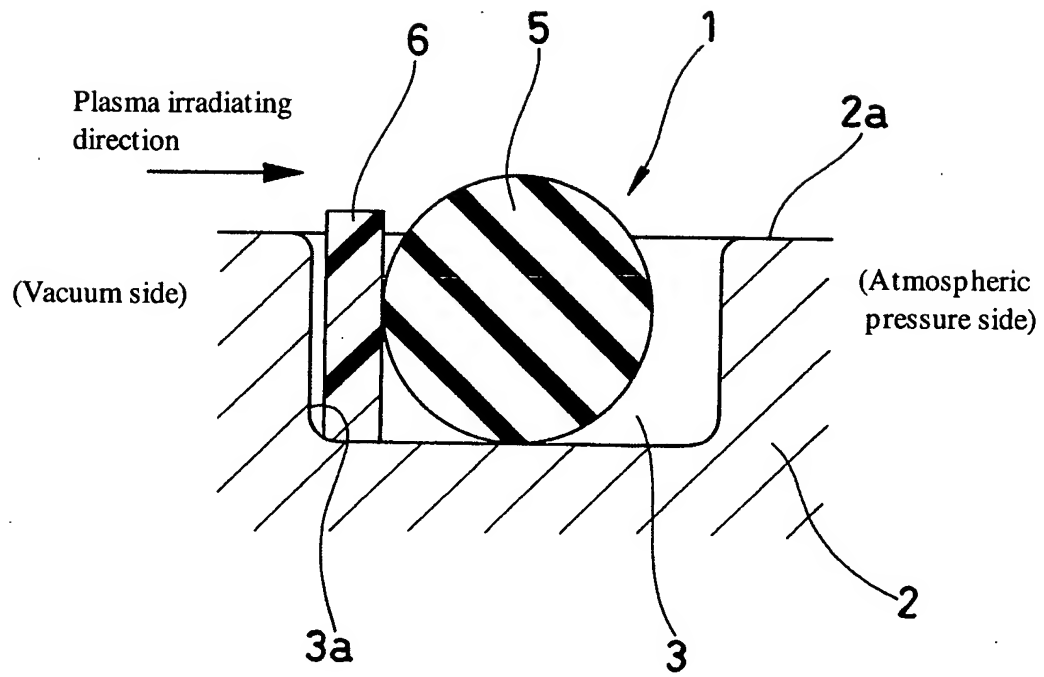


FIG. 5

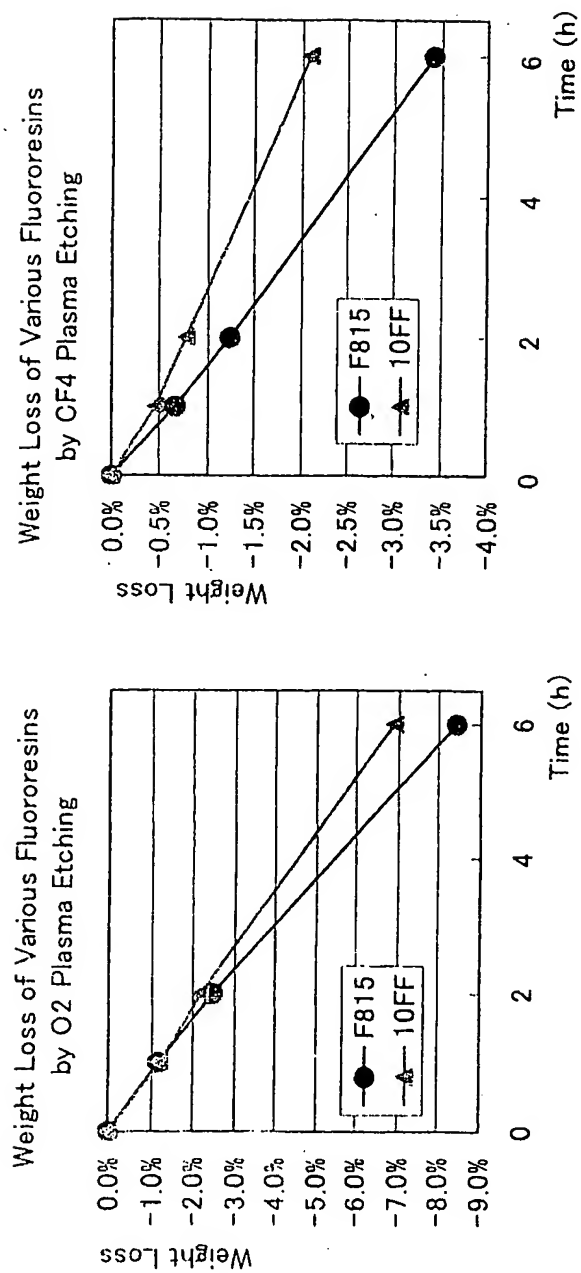


FIG. 6

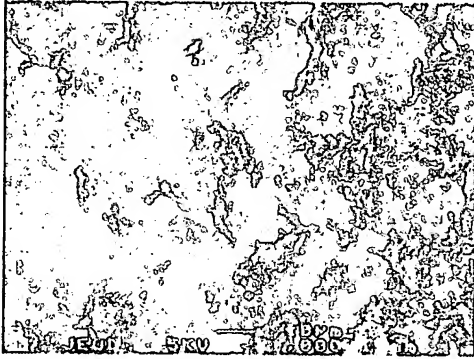
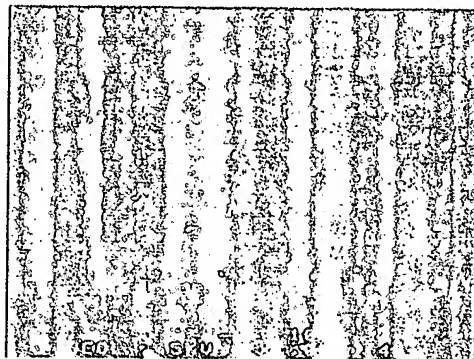
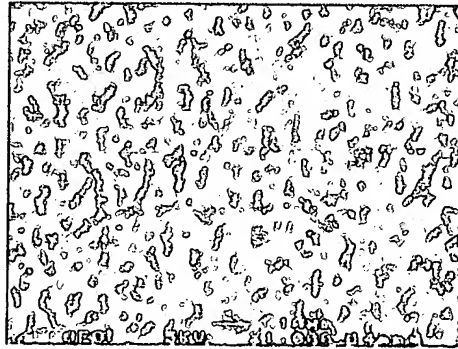
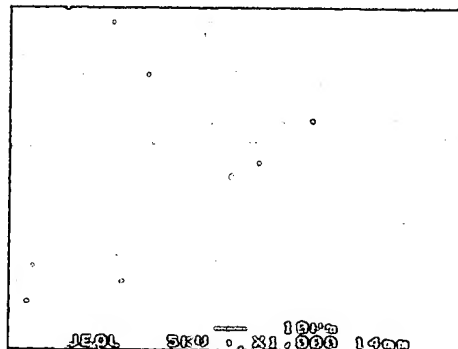
Plasma resistance FKM(O ₂):Direct irradiation	Plasma resistance FKM(O ₂): PTFE Protection
 <p>Surface roughness is generated</p>	 <p>No surface roughness is generated</p>
Plasma resistance FKM(CF ₄): Direct irradiation	Plasma resistance FKM(CF ₄): PTFE Protection
 <p>Surface roughness (etching) is generated</p>	 <p>No surface roughness is generated</p>

FIG. 7

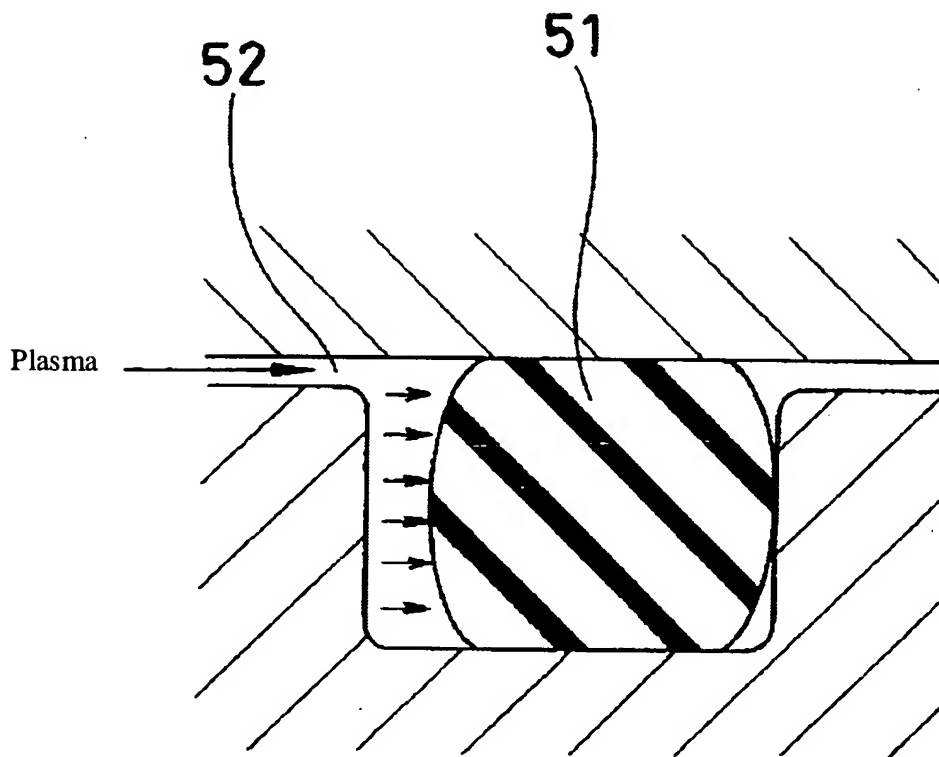


FIG. 8

